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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application: Yi Sun CHUNG

] GRP ART UNIT:

Serial No: 10/738,398

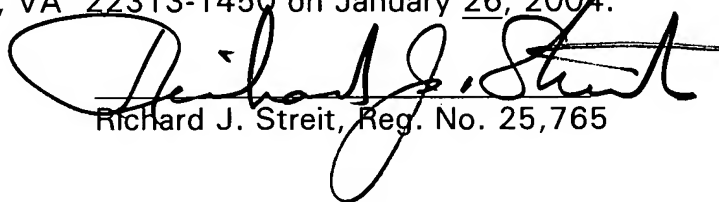
] Ex.:

Filed: December 17, 2003

For: METHOD FOR FORMING METAL-INSULATOR-METAL CAPACITOR OF SEMICONDUCTOR DEVICE

Certification under 37 CFR 1.8(a)

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with The United States Postal Service with sufficient postage as first class mail in an envelope addressed to The Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450 on January 26, 2004.



Richard J. Streit, Reg. No. 25,765

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

APPOINTMENT OF ASSOCIATE ATTORNEY

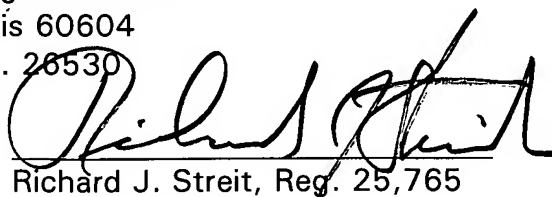
Dear Sir:

The undersigned Attorney for Applicant in the above identified application for Letters Patent, hereby appoints **Woochoon William Park, Reg. P-55,523** as my Associate Attorney, to prosecute this application, to make alterations and amendments therein, to receive the patent, and to transact all business in the United States Patent & Trademark Office connected therewith.

Please address and send all correspondence to:

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Dated: January 26, 2004



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